CLAIMS

This listing of claims will replace all prior versions, and listings, of the claims:

1. (currently amended) A method for reading the magnetization orientation of a memory cell, the method comprising:

applying a magnetic field to the memory cell, the magnetic field having a magnitude less than a magnitude required to alter the magnetization orientation of the memory cell;

observing any change in resistance of the memory cell as the magnetic field is applied; and

determining the magnetization orientation based upon the observed change in resistance of the memory cell.

2. (currently amended) The method of claim 1, A method for reading the magnetization orientation of a memory cell, the method comprising:

applying a magnetic field to the memory cell:

observing any change in resistance of the memory cell as the magnetic field is applied; and

determining the magnetization orientation based upon the observed change in resistance of the memory cell, wherein the magnetic field is a negative magnetic field and wherein determining the magnetization orientation includes determining the memory cell is in a parallel magnetization orientation if there is a change in resistance of the memory cell.

3. (currently amended) The method of claim 1, A method for reading the magnetization orientation of a memory cell, the method comprising:

applying a magnetic field to the memory cell;

observing any change in resistance of the memory cell as the magnetic field is applied; and

determining the magnetization orientation based upon the observed change in resistance of the memory cell, wherein the magnetic field is a negative magnetic field and wherein

determining the magnetization orientation includes determining the memory cell is in an anti-parallel magnetization orientation if there is no change in resistance of the memory cell.

4. (canceled)

- 5. (original) The method of claim 1, wherein the memory cell comprises a sense layer having an alterable magnetization orientation and a reference layer having a fixed magnetization orientation, and wherein the sense layer is shaped to enhance an edge domain effect of the memory cell.
- 6. (original) A method for reading data from a selected memory cell in an array of memory cells, the selected memory cell being positioned between a first write line and a second write line, the method comprising:

supplying a first current in the first write line;

detecting any change in resistance R of the selected memory cell as the first current is supplied to the first write line;

reversing the first current in the first write line;

detecting any change in resistance R of the selected memory cell as the reversed first current is supplied to the first write line; and

determining the magnetization orientation of the selected memory cell based on the detected change in resistance R of the selected memory cell as the first current and the reversed first current are supplied to the first write line.

- 7. (original) The method of claim 6, wherein supplying the first current does not alter the magnetization orientation of the selected memory cell.
- 8. (original) The method of claim 6, wherein determining the magnetization orientation of the selected memory cell includes determining a $\delta R/\delta H$ curve for the selected memory cell, where R is the measured resistance and H is the magnetic field strength.

- 9. (original) The method of claim 8, wherein determining a $\delta R/\delta H$ curve for the selected memory cell includes sampling the resistance of the selected memory cell at a plurality of different magnetic fields about the first line.
- 10. (original) The method of claim 6, wherein the array of memory cells is a magnetic random access memory device.
- 11. (original) The method of claim 6, wherein determining the magnetization orientation of the selected memory cell includes determining the memory cell is in a parallel magnetization orientation if there is a change in resistance of the memory cell, and determining the memory cell is in an anti-parallel magnetization orientation if there is no change in resistance of the memory cell.
- 12. (original) The method of claim 6, further comprising supplying a second current in the second write line while the first current is supplied to the first write line.
- 13. (original) A method for detecting the magnetization orientation of a memory cell, the memory cell operatively positioned between a first conductor and a second conductor, the method comprising:

creating a first magnetic field about the first conductor;

creating a second magnetic field about the second conductor;

observing changes in the resistance of the memory cell under the influence of the first and second magnetic fields;

replacing the second magnetic field with a third magnetic field; and observing changes in the resistance of the memory cell under the influence of the first and third magnetic fields.

- 14. (original) The method of claim 13, wherein the third magnetic field has a polarization direction opposite a polarization direction of the second magnetic field.
- 15. (original) The method of claim 13, wherein creating a magnetic field about the conductors includes supplying electric currents through the conductors.

- 16. (original) The method of claim 13, wherein the first and second magnetic fields do not alter the magnetization orientation in the memory cell.
- 17. (original) The method of claim 13, wherein the first and third magnetic fields do not alter the magnetization orientation in the memory cell.
- 18. (original) The method of claim 13, wherein observing changes in the resistance of the memory cell includes measuring a $\delta R/\delta H$ curve for the memory cell, where R is the measured resistance and H is the magnetic field strength.
- 19. (original) The method of claim 18, wherein measuring a $\delta R/\delta H$ curve includes sampling the resistance of the memory cell at a plurality of magnetic fields.
- 20. (original) The method of claim 13, wherein the memory cell is in an array of memory cells.
- 21. (original) The method of claim 13, wherein the memory cell is in a magnetic random access memory device.
- 22. (original) A system for reading the magnetization orientation of a memory cell, the system comprising:
- a memory cell operatively positioned between a first conductor and a second conductor;
- a current source for applying a variable current to the first conductor and a corresponding variable magnetic field to the memory cell;
- a resistance measurement module for measuring change in resistance of the memory cell with change in the applied magnetic field; and
- a comparator module for comparing the measured change in resistance with change in applied magnetic field to a model change in resistance with change in applied magnetic field.

- 23. (original) The system of claim 22, wherein the memory cell is in an array of memory cells.
- 24. (original) The system of claim 22, wherein the memory cell comprises a sense layer having an alterable magnetization orientation and a reference layer having a fixed magnetization orientation.
- 25. (original) The system of claim 24, wherein the sense layer is shaped to enhance an edge domain effect of the memory cell.
- 26. (original) The system of claim 22, wherein the measured and model change in resistance with change in applied magnetic field are $\delta R/\delta H$ curves, where R is the memory cell resistance and H is the magnetic field strength.
- 27. (original) The system of claim 22, wherein the model change in resistance with change in applied magnetic field is a hysteresis loop.
- 28. (original) A system for reading the magnetization orientation of a memory cell, the system comprising:

a memory cell operatively positioned between a first conductor and a second conductor;

means for applying a variable current to the first conductor and a corresponding variable magnetic field to the memory cell;

means for measuring change in resistance of the memory cell with change in the applied magnetic field; and

means for comparing the measured change in resistance with change in applied magnetic field to a model change in resistance with change in applied magnetic field.

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- 29. (original) The system of claim 28, wherein the measured and model change in resistance with change in applied magnetic field are $\delta R/\delta H$ curves, where R is the memory cell resistance and H is the magnetic field strength.
- 30. (original) The system of claim 28, wherein the model change in resistance with change in applied magnetic field is a hysteresis loop.